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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yamaguchi, et al.

Docket No.: TI-31471

#6/9

Examiner: Im, Junghwa M.

Serial No.: 10/087,556

Filed: 03/01/02

Art Unit: 2811

12-24-02

For: Semiconductor Device and Bump Formation Method

Payton

Amendment under 37 CFR 1.111

Assistant Commissioner of Patents  
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that this correspondence is being deposited with  
the U.S. Postal Service as First Class Mail in an envelope addressed  
to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

12-11-02

*Michael K. Skrehot*

Michael K. Skrehot, Reg. No. 36,682

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 09/11/02. They are respectfully submitted as a full and complete response to that Action. The Commissioner is hereby requested and authorized to charge any fees necessary for the filing of the enclosed papers to deposit account number 20-0668 of Texas Instruments Incorporated.

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